

Title (en)

PRODUCTION OF CARBON AND CARBON-BASED MATERIALS

Title (de)

HERSTELLUNG VON CARBON- UND AUF CARBONBASIERENDE MATERIALIEN

Title (fr)

PRODUCTION DE CARBONE ET DE MATERIAUX A BASE DE CARBONE

Publication

**EP 1303644 A4 20080109 (EN)**

Application

**EP 01951233 A 20010717**

Priority

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Abstract (en)

[origin: WO0206554A1] The present invention relates to the depositing of carbon and carbon-based materials to produce hard carbon films or carbon-based films. The present methods for producing carbon films and carbon-based films include chemical vapour deposition and filtered arc systems. Both have problems. The present invention discloses a method and apparatus which utilises an arc system comprising an anode and a cathode both of graphite. The graphite anode is used to produce the carbon or carbon-based film precursor material. In order to control the quality and rate of deposition of the precursor material onto a substrate, the arc attachment area to the anode is controlled. Minimising the arc attachment area can increase the rate of deposition.

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Citation (search report)

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Designated contracting state (EPC)

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DOCDB simple family (publication)

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